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Serial No.: Not yet assigned

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For: METHOD OF MANUFACTURING  
METALLISED SUBSTRATE MATERIALS

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INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In the interest of full disclosure, the following items are herewith identified in Form PTO-1449 and a copy of the same is hereby provided, for the convenience of the U.S. Patent and Trademark Office.

This Information Disclosure Statement is being filed before the mailing date of the first official action.

U.S. PATENTS

- (AA) U.S. Patent No. 3,294,059, Barnes et al, issued December 27, 1966. Cited as Category "A" in the International Search Report.
- (AB) U.S. Patent No. 4,717,587, Suhr et al, issued January 5, 1988. Cited as Category "A" in the International Search Report.
- (AC) U.S. Patent No. 4,990,363, Suhr et al, issued February 5, 1991. Cited as Category "A" in the International Search Report.

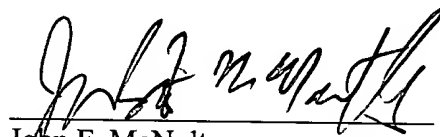
FOREIGN PATENTS

- (AL) **German Patent 35 10 982 A1**, Harald Suhr, et al, dated September 25, 1986. See page 3, third full paragraph of the instant application.
- (AM) **German Patent 35 12 196 A1**, Wilhelm Senske et al, dated October 16, 1986. Cited as Category "A" in the International Search Report.
- (AN) **German Patent 37 44 062 A1**, Harald Suhr et al, dated July 13, 1989. See page 5, second full paragraph of the instant application.
- (AO) **German Patent 38 06 587 A1**, Harald Suhr, et al, dated September 7, 1989. See page 2, last paragraph of the instant application.
- (AP) **German Patent 44 38 791 A1**, Ralf Schulz et al, dated April 25, 1996. See page 3, first full paragraph of the instant application.
- (AQ) **International Application PCT/DE95/01501, Pub. No. WO 96/12051**, Heinrich Meyer et al, dated October 18, 1995. See page 3, second full paragraph of the instant application.

OTHER DOCUMENTS

- (AR) *Thin Palladium Films Prepared by Metal-Organic Plasma-Enhanced Chemical Vapor Deposition*", Thin Solid Films, Band 157 (1988), p. 81-86. See page 3, last paragraph of the instant application.

Respectfully submitted,

  
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